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**INFORMATION DISCLOSURE  
CITATION**

(Use several sheets if necessary)

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(Assigned)Applicant  
**WARD-CLOSE et al**

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March 25, 2005

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**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CSK	5,147,451	9/1992	Leland			
	4,727,928	3/1988	De Vynck et al			
	4,114,251	9/1978	Southern et al			
	3,442,321	5/1969	Devillard et al			
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CGC	5,336,378	8/1994	Nishimura et al			

**FOREIGN PATENT DOCUMENTS**

TRANSLATION

	DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
NOT REL'D	<del>0 047 665</del>	<del>3/1982</del>	<del>EPO</del>				
	<del>2 359 564</del>	<del>8/2001</del>	<del>GB</del>				
	<del>0 153 296</del>	<del>8/1983</del>	<del>EPO</del>				
	<del>63183145</del>	<del>7/1988</del>	<del>Japan</del>				
	<del>0 408 383</del>	<del>1/1991</del>	<del>EPO</del>				
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	<del>2 256 716</del>	<del>6/1974</del>	<del>Germany</del>				
	<del>WO 9100158</del>	<del>1/1991</del>	<del>WIPO</del>				
	<del>2 151 761</del>	<del>7/1985</del>	<del>GB</del>				
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	<del>1091101</del>	<del>11/1967</del>	<del>GB</del>				
	<del>1026768</del>	<del>4/1966</del>	<del>GB</del>				
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**OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)**

NOT RECEIVED	Mac Rae, "Plasma ARC Process System, Reactors, and Applications", Plasma Chemistry and Plasma Processing, Plenum Press, New York, 9(1) SUPPL:855-118 (1989)
"	Bomberger, "The melting of titanium", Journal of Metals - JOM, Metallurgical Society of the Aime, New York 36(12):39-47 (1984)
"	Patent Abstracts of Japan 0124(62) (C-549) (1988)

\*Examiner

Date Considered

12/26/07

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.